

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/536,037
Filing Date March 27, 2000
Inventor Weimin (Michael) Li
Assignee Micron Technology, Inc.
Group Art Unit 2822
Examiner Toniae M. Thomas
Attorney's Docket No. MI22-1398
Customer No. 021567
Title: Low k Interlevel Dielectric Layer Fabrication Methods



To: Box RCE
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

From: James E. Lake
(Tel. 509-624-4276; Fax 509-838-3424)
Wells St. John P.S.
601 W. First Avenue, Suite 1300
Spokane, WA 99201-3828
509-624-4276

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

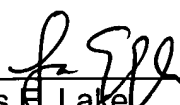
References -- See Attached Form PTO-1449

This Request for Continued Examination (RCE) Application is being filed in an abundance of caution to ensure consideration of the references listed on the attached form PTO-1449.

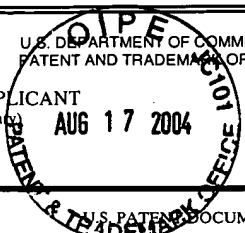
The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. No admission is made regarding whether the submitted references are prior art.

Respectfully submitted,

Dated: 17 Aug 2004

By: 
James E. Lake
Reg. No. 44,854

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|---|-----------------|--|---------|-----------------|--------------------------------|----------------------------|--------------------------|--|
| Form PTO-1449 | |  | | | ATTY. DOCKET NO. MI22-1398 | | SERIAL NO. 09/536,037 | |
| LIST OF ART CITED BY APPLICANT (Use several sheets if necessary) | | | | | APPLICANT Weimin Li, et al. | | | |
| | | | | | FILING DATE March 27, 2000 | | GROUP 2822 | |
| U.S. PATENT DOCUMENTS | | | | | | | | |
| *Examiner Initial | Document Number | Date | Name | Class | Subclass | Filing Date If Appropriate | | |
| | AA | 6,153,504 | 11/2000 | Shields et al | | | | |
| | AB | 4,971,655 | 11/1990 | Stafano et al | | | | |
| | AC | 6,498,084 B2 | 12,2002 | Bergemont | | | | |
| | AD | 5,036,383 | 07/1991 | Mori | | | | |
| | AE | 5,593,741 | 01/1997 | Ikeda | | | | |
| | AF | | | | | | | |
| | AG | | | | | | | |
| | AH | | | | | | | |
| | AI | | | | | | | |
| | AJ | | | | | | | |
| | AK | | | | | | | |
| | AL | | | | | | | |
| FOREIGN PATENT DOCUMENTS | | | | | | | | |
| | Document Number | Date | Country | Class | Subclass | Translation | | |
| | | | | | | Yes | No | |
| | AM | 08-045926A | 02/1996 | Japan | | | | |
| | AN | JP8051058 | 02/1996 | Japan | | | | |
| | AO | JP63316476 | 12/1998 | Japan | | | | |
| | AP | JP8078322 | 03/1996 | Japan | | | | |
| | AQ | 10-163083 | 06/1998 | Japan | | | | |
| OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.) | | | | | | | | |
| | AR | Wolf, S., Silicon Processing for the VLSI ERA. Vol. 3, The Submicron MOSFET p. 635 | | | | | | |
| | | | | | | | | |
| | AS | | | | | | | |
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| | AT | | | | | | | |
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| EXAMINER | | | | DATE CONSIDERED | | | | |
| *EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. | | | | | | | | |

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Inventor Weimin (Michael) Li et al.
Assignee Micron Technology, Inc.
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Examiner Toniae M. Thomas
Attorney's Docket No. MI22-1398
Title: Low k Interlevel Dielectric Layer Fabrication Methods

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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References - - See attached Form PTO-1449

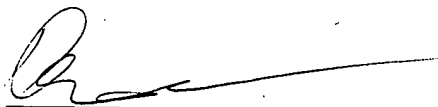
In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

This Supplemental Information Disclosure Statement is being filed after the filing of the Request for Continued Examination (RCE) Application and before receipt of the first Office Action. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. §1.17(p) to Deposit Account No. 23-0925. Please credit Deposit Account No. 23-0925 with any overpayment of the above fee.

The listed references were cited by, or submitted to, the Office in the parent, co-pending application of the above-identified application. The above-identified application is a divisional application of co-pending application Serial No. 09/388,826, filed September 1, 1999. Such prior disclosure is sufficient for the above-identified application as far as copies of the references are concerned. 37 C.F.R. § 1.98(d) and MPEP § 609(2). Citation of these references is respectfully requested.

Respectfully submitted,

Date: 2/11/04



David G. Latwesen Ph.D.
Reg. No. 38,533

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|---|--|--|--|--------------------------------|--|--------------------------|--|
| Form PTO-1449 | | U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE | | ATTY. DOCKET NO. MI22-1398 | | SERIAL NO. 09/536,037 | |
| LIST OF ART CITED BY APPLICANT (Use several sheets if necessary) | | | | APPLICANT Weimin Li, et al. | | | |
| | | | | FILING DATE March 27, 2000 | | GROUP 2822 | |

| U.S. PATENT DOCUMENTS | | | | | | | |
|-----------------------|-----------------|--------------|---------|---------------|----------|----------------------------|--|
| *Examiner Initial | Document Number | Date | Name | Class | Subclass | Filing Date If Appropriate | |
| | AA | 6,503,818 B1 | 01/2003 | Jang | | | |
| | AB | 6,486,061 B1 | 11/2002 | Xia et al. | | | |
| | AC | 6,486,057 B1 | 11/2002 | Yeh et al. | | | |
| | AD | 6,465,372 B1 | 10/2002 | Xia et al. | | | |
| | AE | 6,444,593 B1 | 09/2002 | Ngo et al. | | | |
| | AF | 6,436,808 B1 | 08/2002 | Ngo et al. | | | |
| | AG | 6,435,943 B1 | 08/2002 | Chang et al. | | | |
| | AH | 6,429,115 B1 | 08/2002 | Tsai et al. | | | |
| | AI | 6,284,677 B1 | 09/2001 | Hsiao et al. | | | |
| | AJ | 6,030,901 | 02/2000 | Hopper et al. | | | |
| | AK | 6,133,618 | 10/2000 | Steiner | | | |
| | AL | 5,994,217 | 11/1999 | Ng | | | |

| FOREIGN PATENT DOCUMENTS | | | | | | | |
|--------------------------|---------|---------|-------|----------|-------------|----|--|
| Document Number | Date | Country | Class | Subclass | Translation | | |
| | | | | | Yes | No | |
| AM | 8046186 | 02/1996 | Japan | | | | |
| AN | 8046186 | 2/1996 | Japan | | X | | |
| AO | 7201716 | 08/1995 | Japan | | | | |
| AP | 7201716 | 08/1995 | Japan | | X | | |
| AQ | 8046188 | 02/1996 | Japan | | | | |

| OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.) | | |
|---|--|--|
| AR | | Wolf, S., Silicon Process., V.1 407-413 |
| | | |
| AS | | Wolf, S., Silicon Process., Vol. 2 48-49 and 435 |
| | | |
| AT | | |
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| EXAMINER | DATE CONSIDERED |
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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|--|----|--|---------|--------------------------------|-------|--------------------------|----------------------------|
| Form PTO-1449 | | U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE | | ATTY. DOCKET NO. M122-1398 | | SERIAL NO. 097536,037 | |
| LIST OF ART CITED BY APPLICANT (Use several sheets if necessary) | | | | APPLICANT Weimin Li, et al. | | | |
| | | | | FILING DATE March 27, 2000 | | GROUP 2822 | |
| U.S. PATENT DOCUMENTS | | | | | | | |
| *Examiner Initial | | Document Number | Date | Name | Class | Subclass | Filing Date If Appropriate |
| | AA | 5,985,519 | 11/1999 | Kakamu et al. | | | |
| | AB | 5,747,388 | 05/1998 | Kusters et al | | | |
| | AC | 5,639,687 | 06/1997 | Roman et al | | | |
| | AD | 5,498,555 | 03/1996 | Lin | | | |
| | AE | | | | | | |
| | AF | | | | | | |
| | AG | | | | | | |
| | AH | | | | | | |
| | AI | | | | | | |
| | AJ | | | | | | |
| | AK | | | | | | |
| | AL | | | | | | |
| FOREIGN PATENT DOCUMENTS | | | | | | | |
| | | Document Number | Date | Country | Class | Subclass | Translation |
| | | | | | | | Yes No |
| | AM | 6232113 | 08/1994 | Japan | | | |
| | AN | | | | | | |
| | AO | | | | | | |
| | AP | | | | | | |
| | AQ | | | | | | |
| OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.) | | | | | | | |
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| FEB-12-2004 10:06 | WELLS ST JOHN PS | 5098383424 P.01 |
| IN THE UNITED STATES PATENT AND TRADEMARK OFFICE | | |
| Patent Application Serial No. 09/536,037 | | |
| Filing Date March 27, 2000 | | |
| Inventor Weimin Li | | |
| Assignee Micron Technology, Inc. | | |
| Group Art Unit 2822 | | |
| Examiner T. Thomas | | |
| Attorney Docket No. MI22-1398 | | |
| Title: Low k Interlevel Dielectric Layer Fabrication Methods | | |
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| Commissioner for Patents P.O. Box 1450 Art Unit 2822 Alexandria, VA 22313-1450 | | |
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| 3. Supplemental Information Disclosure Statement; PTO-1449 | | |
| Dated: Feb 12, 2004 | By: Gail Wright | |
| | Telephone No. | (509) 824-4276 |
| | Facsimile No. | (509) 838-3424 |
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***** -5098383424 - ***** - 5098383424- *****

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Patent Application Serial No. 09/536,037
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Inventor Weimin Li
Assignee Micron Technology, Inc.
Group Art Unit 2822
Examiner..... T. Thomas
Attorney Docket No. MI22-1398
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Gail Wright
Telephone No. (509) 624-4276
Facsimile No. (509) 838-3424

NUMBER OF PAGES IN FACSIMILE: 5

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Assignee Micron Technology, Inc.
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Examiner T. Thomas
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Gail Wright

Telephone No.

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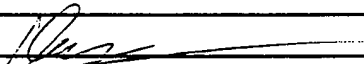
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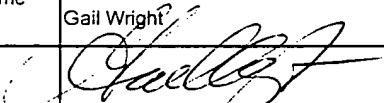
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| TRANSMITTAL FORM <i>(to be used for all correspondence after initial filing)</i> | Application Number | 09/536,037 |
| | Filing Date | March 27, 2000 |
| | First Named Inventor | Weimin Li |
| | Art Unit | 2822 |
| | Examiner Name | T. Thomas |
| Total Number of Pages in This Submission | Attorney Docket Number | MI22-1398 |

| ENCLOSURES (Check all that apply) | | |
|--|--|--|
| <input type="checkbox"/> Fee Transmittal Form <input type="checkbox"/> Fee Attached <input type="checkbox"/> Amendment/Reply <input type="checkbox"/> After Final <input type="checkbox"/> Affidavits/declaration(s) <input type="checkbox"/> Extension of Time Request <input type="checkbox"/> Express Abandonment Request <input checked="" type="checkbox"/> Information Disclosure Statement <input type="checkbox"/> Certified Copy of Priority Document(s) <input type="checkbox"/> Response to Missing Parts/Incomplete Application <input type="checkbox"/> Response to Missing Parts under 37 CFR 1.52 or 1.53 | <input type="checkbox"/> Drawing(s) <input type="checkbox"/> Licensing-related Papers <input type="checkbox"/> Petition <input type="checkbox"/> Petition to Convert to a Provisional Application <input type="checkbox"/> Power of Attorney, Revocation <input type="checkbox"/> Change of Correspondence Address <input type="checkbox"/> Terminal Disclaimer <input type="checkbox"/> Request for Refund <input type="checkbox"/> CD, Number of CD(s) _____ <div style="border: 1px solid black; padding: 2px; margin-top: 5px;">Remarks</div> | <input type="checkbox"/> After Allowance communication to Technology Center (TC) <input type="checkbox"/> Appeal Communication to Board of Appeals and Interferences <input type="checkbox"/> Appeal Communication to TC (Appeal Notice, Brief, Reply Brief) <input type="checkbox"/> Proprietary Information <input type="checkbox"/> Status Letter <input checked="" type="checkbox"/> Other Enclosure(s) (please identify below): <div style="text-align: center; margin-top: 10px;">PTO-1449</div> |
| <div style="font-size: 2em; opacity: 0.5; transform: rotate(-15deg); position: absolute; top: 50%; left: 50%;">COPY</div> | | |
| SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT | | |
| Firm or Individual name | David G. Latwesen Ph.D. Reg. No. 38,533; Wells St. John P.S. | |
| Signature |  | |
| Date | February 12, 2004 | |

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| Typed or printed name | Gail Wright | |
| Signature |  | Date February 12, 2004 |

This collection of information is required by 37 CFR 1.5. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

If you need assistance in completing the form, call 1-800-PTO-9199 and select option 2.

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